## 'IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Attorney Docket No. 029567.00011

Makiko KITAZOE et al.

Confirmation No.: 8995

Application No.: 10/593,444

Art Unit: 1715

Filed: February 5, 2007

Examiner: J. A. MILLER, JR.

For: UNIT-LAYER POST-PROCESSING CATALYST CHEMICAL-VAPOR-DEPOSITION

APPARATUS AND ITS FILM FORMING METHOD

## AMENDMENT UNDER 37 C.F.R. 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

February 10, 2012

Sir:

In reply to the outstanding Final Office Action dated October 20, 2011, please amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.